

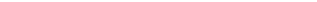
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<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p><i>(Use as many sheets as necessary)</i></p>		Complete if Known	
		Application Number	N/A
		Filing Date	Herewith
		First Named Inventor	Salvatore Pavone
		Art Unit	N/A
		Examiner Name	N/A
Sheet	1	of	2
		Attorney Docket Number	TI 35748

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

Examiner Signature		Date Considered	02/26/07
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	N/A
				Filing Date	Herewith
				First Named Inventor	Salvatore Pavone
				Art Unit	N/A
				Examiner Name	N/A
Sheet	2	of	2	Attorney Docket Number	TI 35748
<i>(Use as many sheets as necessary)</i>					

NON-PATENT LITERATURE DOCUMENTS

NON-PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	✓	<u>DuPont Zyron - Electronic Gases, Technical Bulletin;</u> www.dupont.com/zyron	
MK	✓	M.T. Mocella; "RECENT STUDIES OF c-C4F8, AN OPTIMUM FLUOROCARBON GAS FOR CVD CHAMBER CLEANING"; /www.dupont.com/zyron/pdf/isesh_2001.pdf .	
MK	✓	T.Nishikawa, M. Kataoka, S. Kesari, OL. Zazzera, L. Tousignant; "PROCESS COMPARISONS DURING C3F8 AND C2F6 CVD CHAMBER CLEANING AT ASM JAPAN"; www.asm.com/pdf/chambclean01.pdf .	
MK	✓	Allen Evans, Lance Nevela, Charles C. Allgood; "ADVANCES IN REDUCING PFC EMISSIONS AND GAS COSTS: QUALIFICATION AND IMPLEMENTATION OF C-C4F8 CHAMBER CLEAN GAS IN A NOVELLUS CONCEPT-2 CHEMICAL VAPOR DEPOSITION TOOL"; www.dupont.com/zyron/pdf/southwest_2002.pdf .	
MK		"REDUCING PFC EMISSIONS; A TECHNOLOGY UPDATE"; 1/7/2000 Future Fab Volume 9; Montgomery Research, Inc.; www.future-fab.com/documents.asp?grID=273&d_ID=1184 .	

Examiner Signature		Date Considered	02/26/07
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

Applicant's Unique Citation Designation Number (Optional): Applicant has placed a check mark here. English language translation is desired. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO:** Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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